



Form PTO-1449 (modified)

Atty. Docket No.

2000.106500/DE0260

Serial No.

10/602,192

List of Patents and Publications for Applicant's

Applicant

Markus Nopper and Axel Preusse

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Filing Date:

June 24, 2003

Group:

2811 2825

U.S. Patent Documents

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Foreign Patent Documents

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Other Art

See Page 1

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
CME	A1	2002/0050459 A1	5/02/02	Matsuda <i>et al.</i>	205	118	—
CME	A2	6,479,902 B1	11/12/02	Lopatin <i>et al.</i>	257	774	—
	A3						
	A4						
	A5						

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
CME	B1	EP 1 201 787 A2	5/02/02	Europe	C23C	18/28	Yes
CME	B2	WO 02/45155 A2	6/06/02	PCT	H01L	21/768	Yes
CME	B3	2002356733 A	12/13/02	Japan	C22C	27/04	Yes

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
CME	C1	Shacham-Diamand <i>et al.</i> , "Electroless copper deposition for ULSI," <i>Thin Solid Films</i> , 262:93-103, 1995
CME	C2	Lin <i>et al.</i> , "Interfacial mechanism studies of electroless plated CU films on α -Ta:N layers catalyzed by PIII," <i>J. Vac. Sci. Technol.</i> , 20:733-40, 2002
	C3	

EXAMINER:

C. Ruerthert

DATE CONSIDERED:

10-20-04

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

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Applicant
Markus Nopper and Axel Preusse

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U.S. Patent Documents
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Foreign Patent Documents
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Other Art
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U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
CME	A3	5,969,422	10/19/99	Ting <i>et al.</i>	257	762	—
CME	A4	6,461,675 B2	10/08/02	Paranjpe <i>et al.</i>	427	250	—
	A5						
	A6						
	A7						

Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1						
	B2						
	B3						

Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	
	C2	
	C3	

EXAMINER:

C. Suerhart

DATE CONSIDERED:

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